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U.S. UTILITY Patent Application

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PATENT NUMBER and  
ISSUE DATE

APPL NUM 10003436	FILING DATE 12/06/2001	CLASS 427	SUBCLASS <i>249.7</i>	GAU <del>1762</del>	EXAMINER <i>chen</i>
<b>**APPLICANTS:</b> Veerasamy Vijayan; Petrmichl Rudolph; <div style="text-align: right;"><i>1762</i></div>					
<b>**CONTINUING DATA VERIFIED:</b> THIS APPLICATION IS A CON OF 09/703,709 11/02/2000 WHICH IS A CIP OF 09/657,132 09/07/2000 PAT 6,277,480 WHICH IS A CIP OF 09/627,441 07/28/2000 PAT 6,280,834 AND A CIP OF 09/617,815 07/17/2000 PAT 6,312,808 AND A CIP OF 09/303,548 05/03/1999 PAT 6,261,693 AND A CIP OF 09/442,805 11/18/1999 PAT 6,338,901 AND A CIP OF 09/583,862 06/01/2000 PAT 6,335,086					
<b>** FOREIGN APPLICATIONS VERIFIED:</b>					
PG-PUB DO NOT PUBLISH <input type="checkbox"/>		RESCIND <input type="checkbox"/>		ATTORNEY DOCKET NO 3691-356	
Foreign priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no 35 USC 119 conditions met <input type="checkbox"/> yes <input type="checkbox"/> no Verified and Acknowledged Examiners's initials					
TITLE : Method of ion beam milling a glass substrate prior to depositing a coating system thereon, and corresponding system for carrying out the same					

<b>NOTICE OF ALLOWANCE MAILED</b>		<b>CLAIMS ALLOWED</b>	
		Total Claims	Print Claim for O.G
<b>ISSUE FEE</b>		<b>DRAWING</b>	
Amount Due	Date Paid	Sheeto Drwg.	Figso Drwg. Print Fig.
<input type="checkbox"/> <b>TERMINAL DISCLAIMER</b>		Primary Examiner	
		PREPARED FOR ISSUE	
		Application Examiner	
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